



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Sadwick et al.

SERIAL NO.:

10/775,266

FILING DATE:

February 10, 2004

TITLE:

HINGED STRUCTURES FOR

VACUUM MICROELECTRONICS

AND METHODS OF

MANUFACTURING SAME

ART UNIT:

2821

EXAMINER:

Leith A. Al Nazer

DOCKET NO.:

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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail, postage prepaid, under 37 C.F.R.§ 1.8 on the date indicated below and is addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313

Paul C. Oestreich

01-10-06

Date of Deposit

AMENDMENT AND RESPONSE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action mailed October 12, 2005, Applicants submit the following AMENDMENT AND RESPONSE.

Amendments to the Specification may be found beginning on page 2.

Amendments to the Claims may be found beginning on page 3. Amendments to the Drawings may be found beginning on page 7. Remarks may be found beginning on page 8. A Conclusion may be found on page 16.